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APPLICATION NO. FILING DATE FIRST NAMED INVENTOR ATTORNEY DOCKET NO. CONFIRMATION NO. 10/668,021 09/22/2003 Michael J. Berman 03-0915 1398 **EXAMINER** 24319 08/13/2004 7590 LSI LOGIC CORPORATION RACHUBA, MAURINA T 1621 BARBER LANE ART UNIT PAPER NUMBER MS: D-106 LEGAL MILPITAS, CA 95035

3723 DATE MAILED: 08/13/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

			1
Office Action Summary	Application No.	Applicant(s)	4/
	10/668,021	BERMAN ET AL.	//
	Examiner	Art Unit	#
	M Rachuba	3723	
The MAILING DATE of this communication ap	opears on the cover sheet w	vith the correspondence address	
Period for Reply	IVIC CET TO EVDIDE 21	AONTH/S) EDOM	
A SHORTENED STATUTORY PERIOD FOR REP THE MAILING DATE OF THIS COMMUNICATION  - Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a re - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statu Any reply received by the Office later than three months after the mail earned patent term adjustment. See 37 CFR 1.704(b).		reply be timely filed  irty (30) days will be considered timely.  NTHS from the mailing date of this communication.  BANDONED (35 U.S.C. § 133).	
Status			
1) Responsive to communication(s) filed on	<u></u> .		
2a) This action is <b>FINAL</b> . 2b) ⊠ Th	is action is non-final.		
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is			
closed in accordance with the practice under	Ex parte Quayle, 1935 C.	D. 11, 453 O.G. 213.	
Disposition of Claims			
4)⊠ Claim(s) <u>1-20</u> is/are pending in the applicatio	n.		
4a) Of the above claim(s) is/are withdrawn from consideration.			
5) Claim(s) is/are allowed.			
6) Claim(s) <u>1-20</u> is/are rejected.			
7) Claim(s) is/are objected to.			
8) Claim(s) are subject to restriction and/	or election requirement.		
Application Papers			
9)☐ The specification is objected to by the Examir		_	
10)⊠ The drawing(s) filed on <u>22 September 2003</u> is/are: a)⊠ accepted or b) $\Box$ objected to by the Examiner.			
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).			
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).  11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.			
The oath or declaration is objected to by the E	Examiner. Note the attache	a Office Action of form FTO-192.	
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for foreig a) All b) Some * c) None of:  1. Certified copies of the priority documer 2. Certified copies of the priority documer 3. Copies of the certified copies of the pri application from the International Burea * See the attached detailed Office action for a list	nts have been received.  Its have been received in a contract or a contract or a contract of the contract of t	Application No n received in this National Stage	
Attachment(s)			
1) Notice of References Cited (PTO-892)		Summary (PTO-413)	
<ol> <li>Notice of Draftsperson's Patent Drawing Review (PTO-948)</li> <li>Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08</li> </ol>		(s)/Mail Date Informal Patent Application (PTO-152)	
Paper No(s)/Mail Date	6) Other:		

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## **DETAILED ACTION**

## Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (a) the invention was known or used by others in this country, or patented or described in a printed publication in this or a foreign country, before the invention thereof by the applicant for a patent.
- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 2. Claims 1-20 are rejected under 35 U.S.C. 102(a) or (e) as being clearly anticipated by Lin 6,477,447. Note especially figure 6 and its description.

  Regarding claims 1-9, 19 and 20, '447 discloses the claimed invention used to determine the pressure uniformity of a wafer against a polishing pad, or other pressure components ("In addition, the pressure components applied in the embodiment of the present invention refer to, but not limited to, mechanical CMP pressure related components including a wafer carrier, a polishing pad, and mechanical arm members of a CMP machine.", column 3, lines 37-42). It is inherent that a conditioner for a polishing pad exerts pressure on the pad, and therefore qualifies as a pressure related component. As evidence of inherency, the examiner cites Berman, 6,722,948, which discloses that a conditioning tool to condition a wafer polishing pad is a pressure related component, and that it is known to measure the uniformity of pressure across the conditioning component.

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## Conclusion

 The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Pressure sensing methods and devices using pressure sensitive paper are cited of interest.

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to M Rachuba whose telephone number is 703-308-1361. The examiner can normally be reached on Monday-Thursday from 8:30 AM to 3:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Joseph Hail, can be reached on (703) 308-2687. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

M. Rachuba Primary Patent Examiner